AMENDMENT TRANSMITTAL LETTER (Large Entity) Docket No. Applicant(s): Howard Ge, et al. 34261-8500 Group Art Unit Examiner Customer No. Confirmation No. Application No. Filing Date 10/680,960 10/07/2003 Chacko Davis, Daborah 21611 1756 6075 CHIOFORESIST COATING PROCESS FOR MICROLITHOGRAPHY Invention SEP 2 2 7006 **COMMISSIONER FOR PATENTS:** Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. **CLAIMS AS AMENDED NUMBER EXTRA ADDITIONAL HIGHEST#** CLAIMS REMAINING RATE PREV. PAID FOR CLAIMS PRESENT FEE AFTER AMENDMENT \$0.00 20 Х \$50.00 18 TOTAL CLAIMS \$0.00 0 \$200.00 INDEP! CLAIMS 3 \$0.00 Multiple Dependent Claims (check if applicable) \$180.00 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT □ No additional fee is required for amendment. in the amount of \$180.00 for late filing of IDS ☑ Please charge Deposit Account No. 19-2814 to cover the filing fee is enclosed. ☐ A check in the amount of The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 19-2814 Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form, Provide credit card information and authorization on PTO-2038. **September 19, 2006** Dated: Signature Ehab M. Samuel Reg. No. 57,905 I hereby certify that this correspondence is being deposited with Snell & Wilmer L.L.P. the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, 600 Anton Boulevard, Suite 1400 P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on Costa Mesa, CA 92626-7689 09/19/2006 Phone: 714-427-7404 (Date) Fax: 714-427-7799

CC:

Signature of Person stailing Correspondence

Tanya Kiatkulpiboone

Typed or Printed Name of Person Mailing Correspondence



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Patent Examiner: Chacko Davis, Daborah

Howard Ge, et al.

Group Art Unit: 1756

Serial No.: 10/680,960

Filed: October 7, 2003

Title: PHOTORESIST COATING PROCESS

FOR MICROLITHOGRAPHY

September 19, 2006

Costa Mesa, California 92626

RESPONSE TO OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of June 20, 2006, kindly amend the above-identified application as follows: